

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

e the Application of

Shunichi SEKI et al.

Application No.: 10/686,634

Filed: October 17, 2003

Docket No.: 104741.01

For:

METHOD OF FORMING THIN FILM PATTERNING SUBSTRATE INCLUDING

FORMATION OF BANKS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- This Information Disclosure Statement is being filed (a) within three months of M the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- English-language Abstracts of the non-English language references 1-4 are 冈 attached hereto.
- A computer-generated English translation of the following Japanese references M has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See References 1-5.

Respectfully submitted,

James A. Oliff

Registration No. 27,075

Gang Luo

Registration No. 50,559

JAO:GL/scg

Date: June 29, 2004

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461 JUN 2 9 2004 3

Sheet	1	of	1	

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INFORI	MATIC	ON DISCLOSURE STATEMENT						
	(Use s	everal sheets if necessary)	APPLICA Shunichi	NT(S) SEKI et al.				
				FILING DATE October 17, 2003		GROUP		
		U.S. 1	PATENT DOCU	MENTS				
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME:		CLASS CI		
	l		DATE DA	OCUMENTS				
		DOCUMENT NUMBER	ON PATENT DO	COUN	ITRY	CLASS	SUB CLASS	
	1	JP-A 9-203803 (w/Abst. & trans)	08/1997	JP				
	2	JP-A 9-258208 (w/Abst. & trans)	10/1997	JP	,		,	
	3	JP-A 9-230129 (w/Abst. & trans)	09/1997	JP			<u> </u>	
	4	JP-A 10-153967 (w/Abst. & trans)	06/1998	JP				
	5	JP-B2 2700316 (w/trans.)	10/1997	JP	De casa ata)		<u> </u>	
		OTHER DOCUMENTS (In	cluding Author	, Title, Date, Pertinent F	ages, etc.)			
		K. Imaisumi et al., "Injection and Tra Oxadiazole Derivatives," <i>1997 IEEE</i> Minneapolis, October 19-22, 1997, p	Annual Keport,	Conference on Electric	al Insulation and I	Dielectric Phen	omena,	
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EXAMINER					DATE CON	SIDERED		
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Date: June 29, 2004